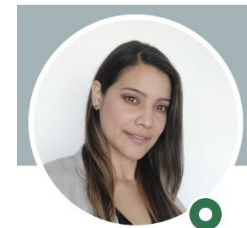


MICRO 423 : ADVANCED ADDITIVE MANUFACTURING TECHNOLOGIES

3D printing using continuous wave light (single photon absorption)

Prof. Christophe Moser

Maria Alvarez Castaño
maria.alvarezcastano@epfl.ch

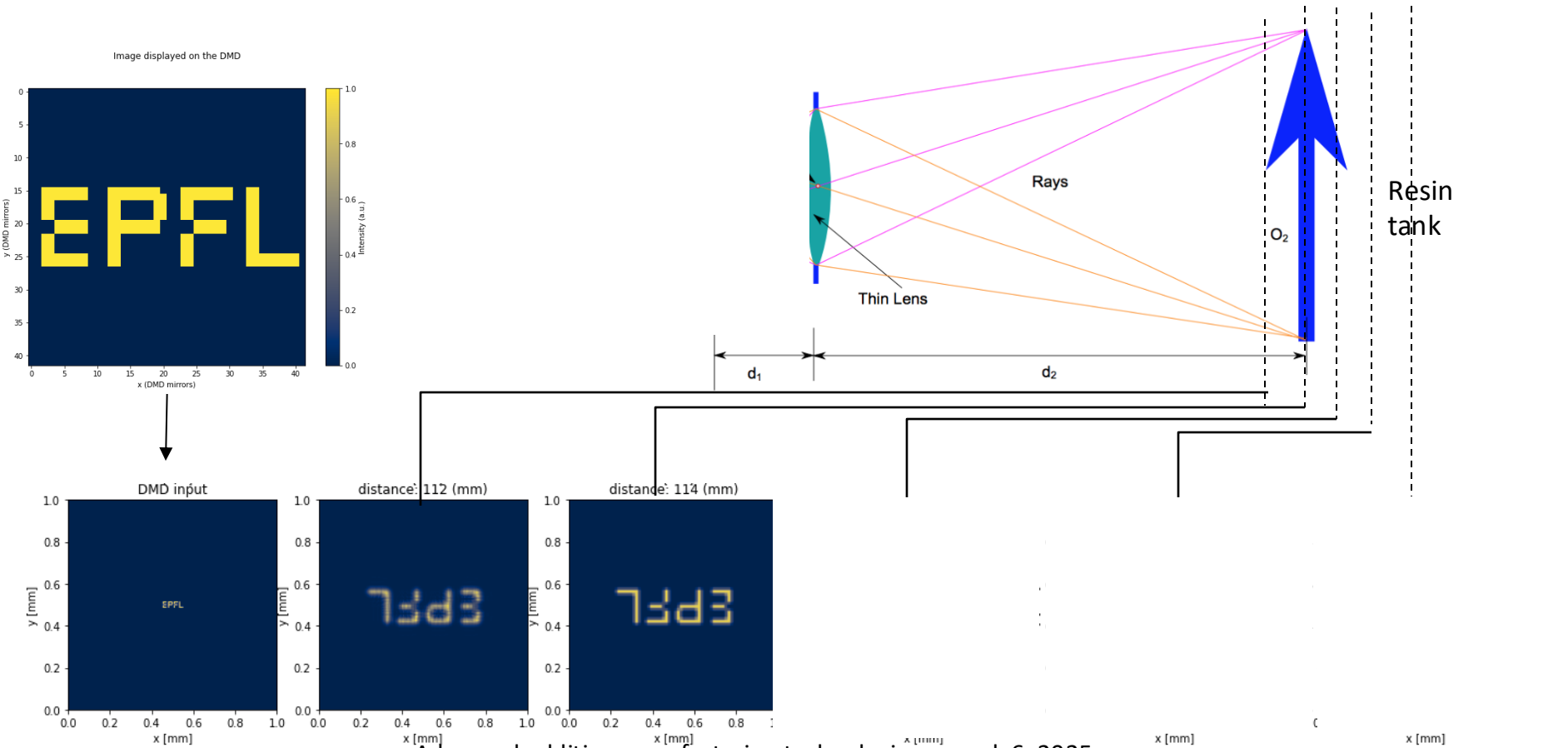


Modules of the 2025 course

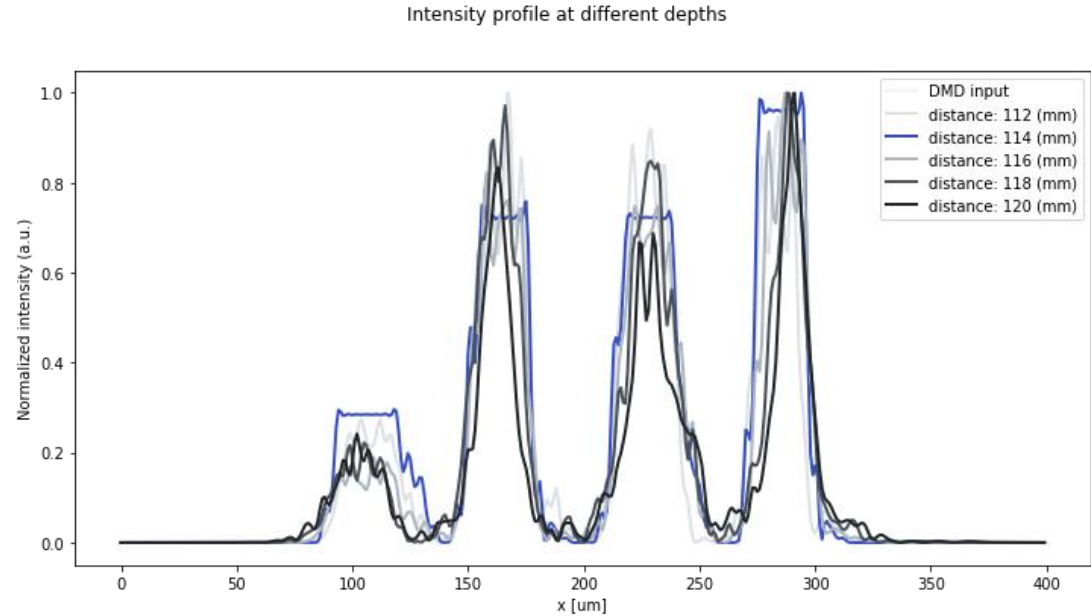
| Topics covered | No | Lecture/Date |
|---|----|--------------|
| VAT Photo polymerization (history) – DLP printer – light engine – part I | 5 | 20.03.2025 |
| DLP printer – chemical components in a photoresin – role of oxygen – CLIP method– part II | 6 | 27.03.2025 |
| Tomographic Volumetric Additive Manufacturing (TVAM) | 7 | 03.04.2025 |
| Two photon Polymerization : nanoscale printing | 8 | 10.04.2025 |
| Two photon Polymerization : applications | 9 | 17.04.2025 |
| EASTER BREAK | | 22.04.2025 |
| Prof. Paul Dalton, University of Oregon: Met Electro Writing (nanoscale) | 10 | 1.05.2025 |
| Gari Arutinov, Holst Center for AM: Mass transfer of microcomponents | 11 | 08.05.2025 |
| Julian Schneider: Scrona | 12 | 15.05.2025 |
| Patrizia Richner: Sonova (hearing aids). // Design Competition | 13 | 22.05.2025 |

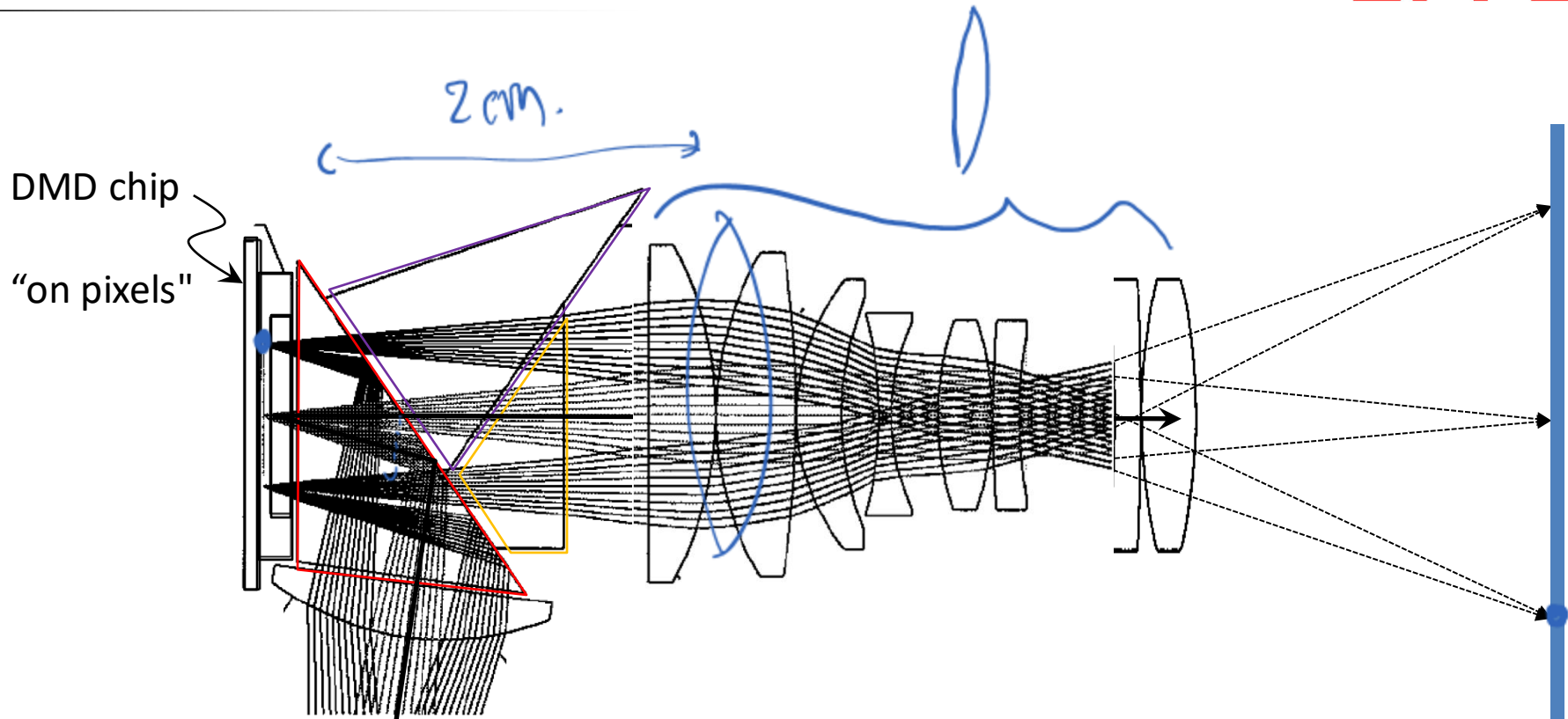
QUIZZ #2

Review: Projection in a DLP printer

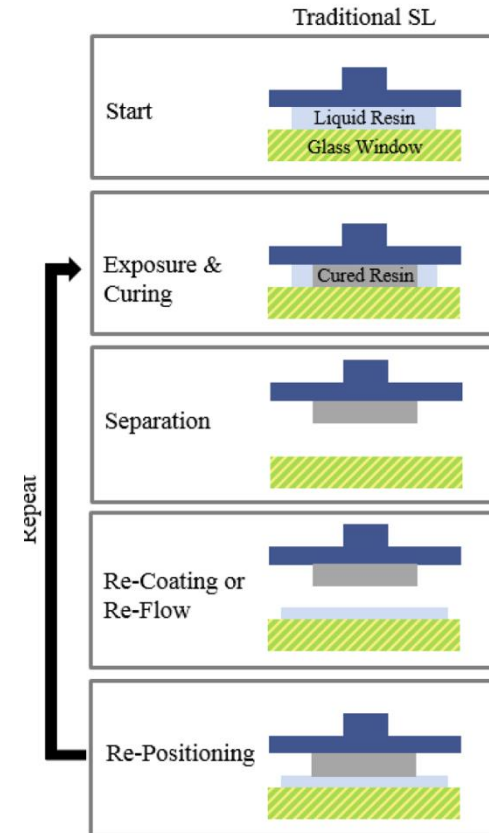
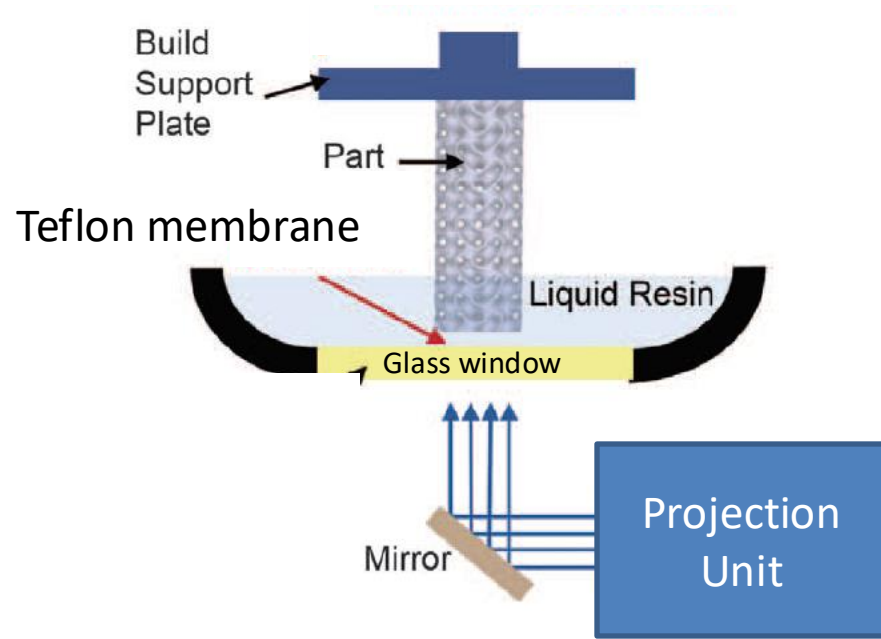


Projecting an image at the wrong plane compromises contrast

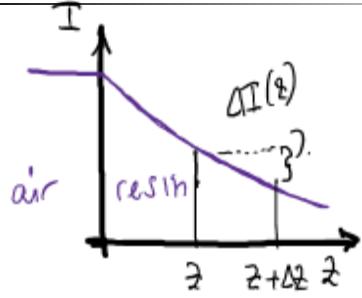




Review: DLP 3D printing



Light absorption defines layer resolution



• $I(z) = I_0 e^{-\alpha z}$: intensity of light ($\frac{\text{Power}}{\text{unit area}}$) at depth z in resin

• $\Delta I(z) = I(z) - I(z + \Delta z)$ absorbed light intensity between z and $z + \Delta z$

$$= \left| \frac{dI}{dz} \right| \cdot \Delta z$$

$$= \alpha I_0 e^{-\alpha z} \cdot \Delta z$$

$$\alpha = \alpha_{PI} + \alpha_{dye}$$

• $\frac{\Delta I(z)}{\Delta z} = \alpha \cdot I_0 e^{-\alpha z}$ absorbed light intensity per unit depth

$D = \frac{\Delta I(z)}{\Delta z} \cdot t = \alpha \cdot t \cdot I_0 e^{-\alpha z}$ absorbed light dose (exposure) per unit depth

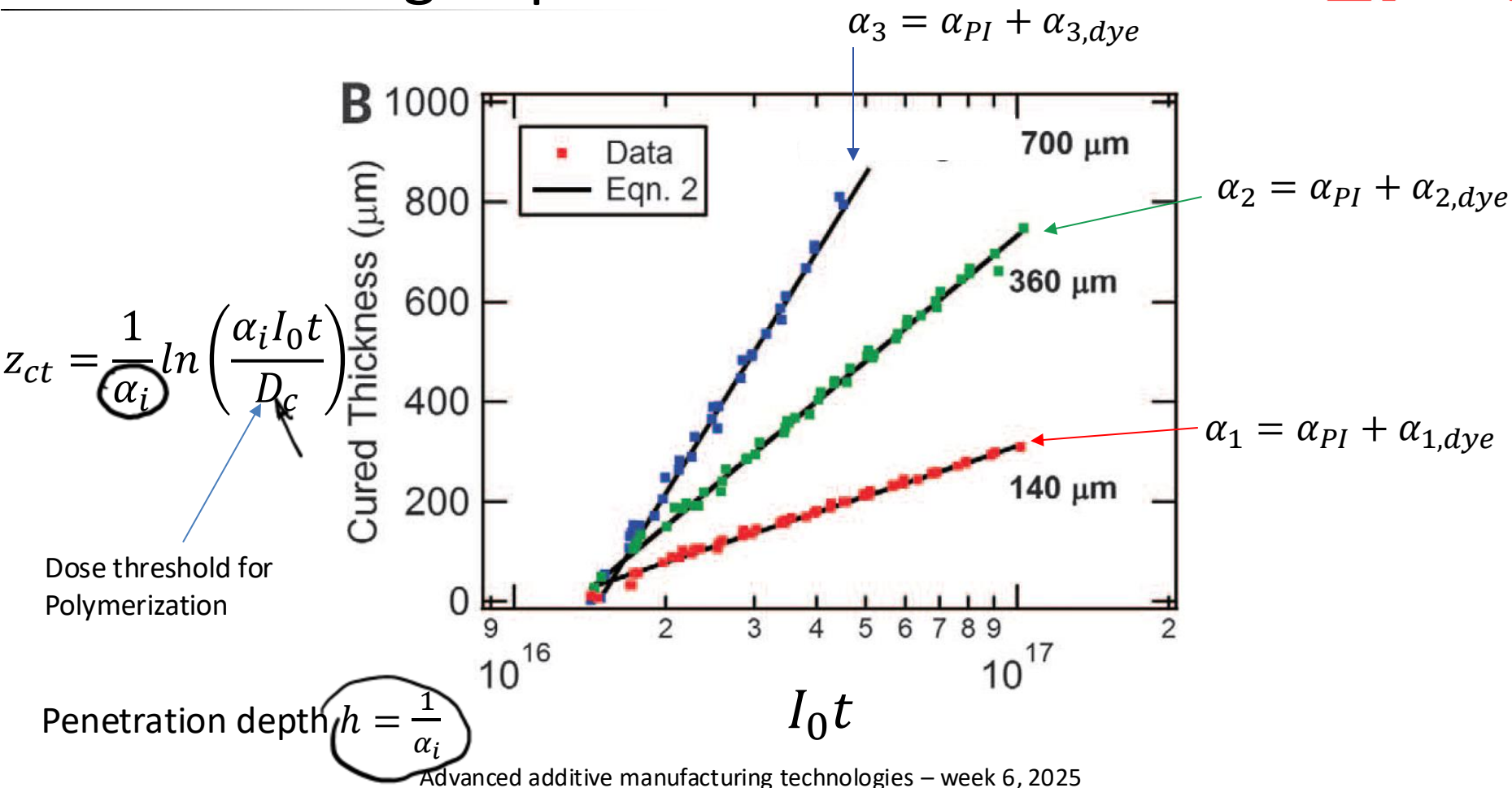
I want to cure (i.e. solidify) a thickness of depth z_{ct} (cure thickness)

$$D_c = \alpha t_c \cdot I_0 e^{-\alpha z_{ct}} \Rightarrow \frac{D_c}{\alpha t_c \cdot I_0} = e^{-\alpha z_{ct}} \Rightarrow \ln \left(\frac{D_c}{\alpha t_c \cdot I_0} \right) = -\alpha z_{ct}$$

$$\Rightarrow z_{ct} = -\frac{1}{\alpha} \ln \left(\frac{D_c}{\alpha t_c \cdot I_0} \right) = \frac{1}{\alpha} \cdot \ln \left(\frac{\alpha \cdot t_c \cdot I_0}{D_c} \right)$$

(the usual critical dose in $\text{mJ}/\text{cm}^2 = E_c$)

Review: Curing Depth



RESIN PARAMETERS

FH1100 STANDARD RESIN

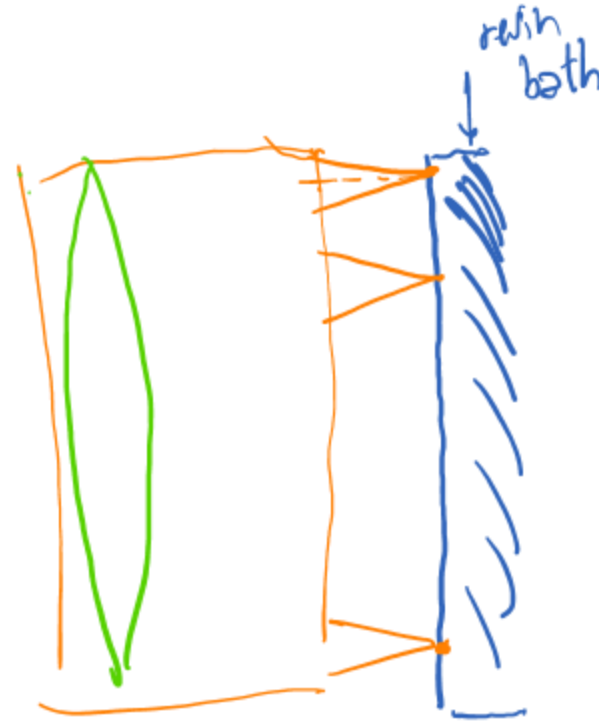
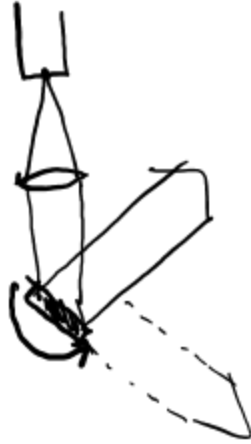
| | |
|---|-----------------------|
| Appearance | Gray |
| Density (g/cm ³) | 1.14 |
| Viscosity (cps) | 350 cps (25°C) |
| Critical Exposure E_c (mJ/cm ²) | 12 mJ/cm ² |
| Penetration Depth (dp) | 0.2 mm |

As comparison
Water has a viscosity of 1 cps at 20°C

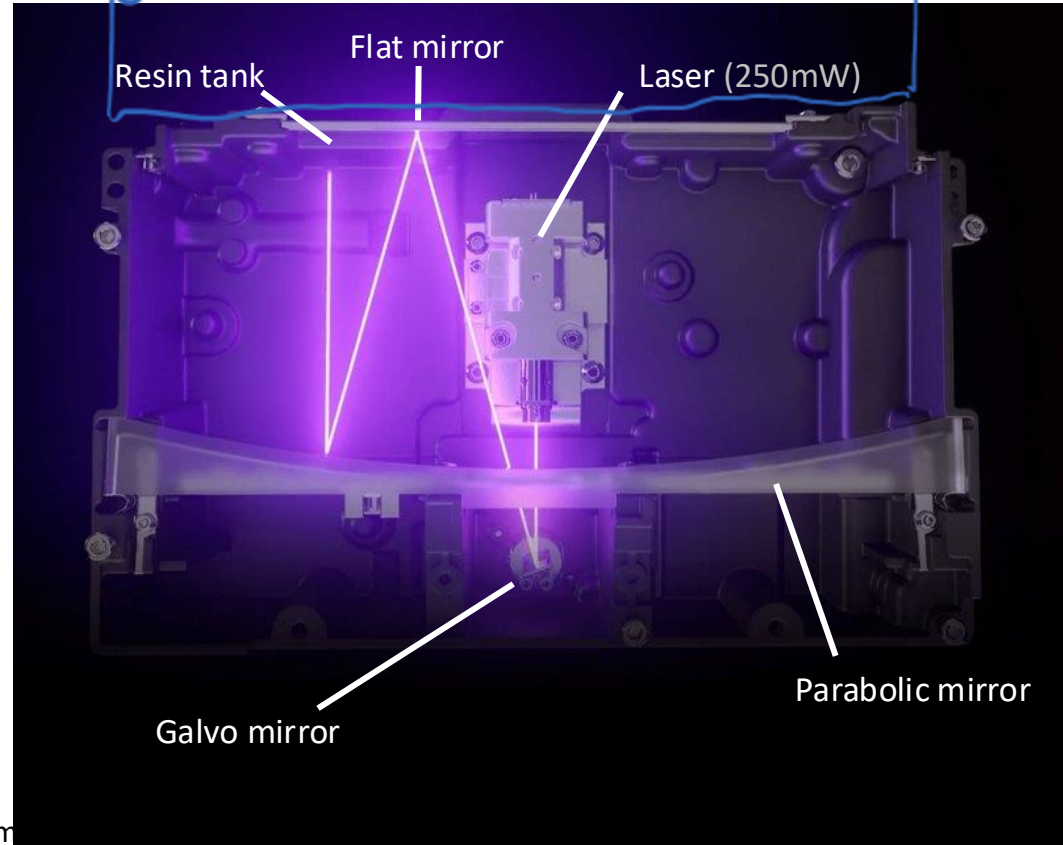
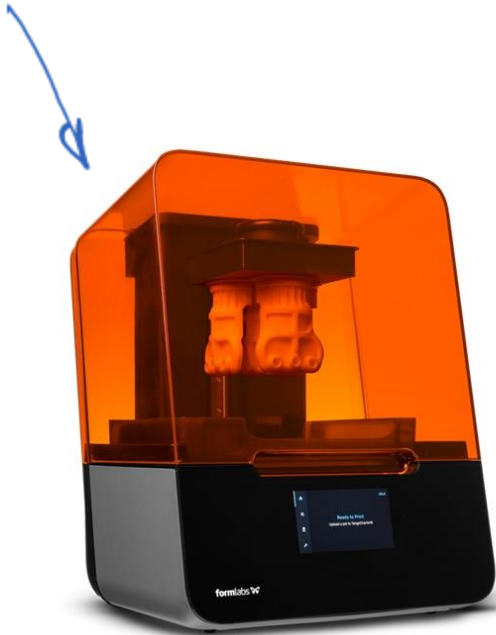


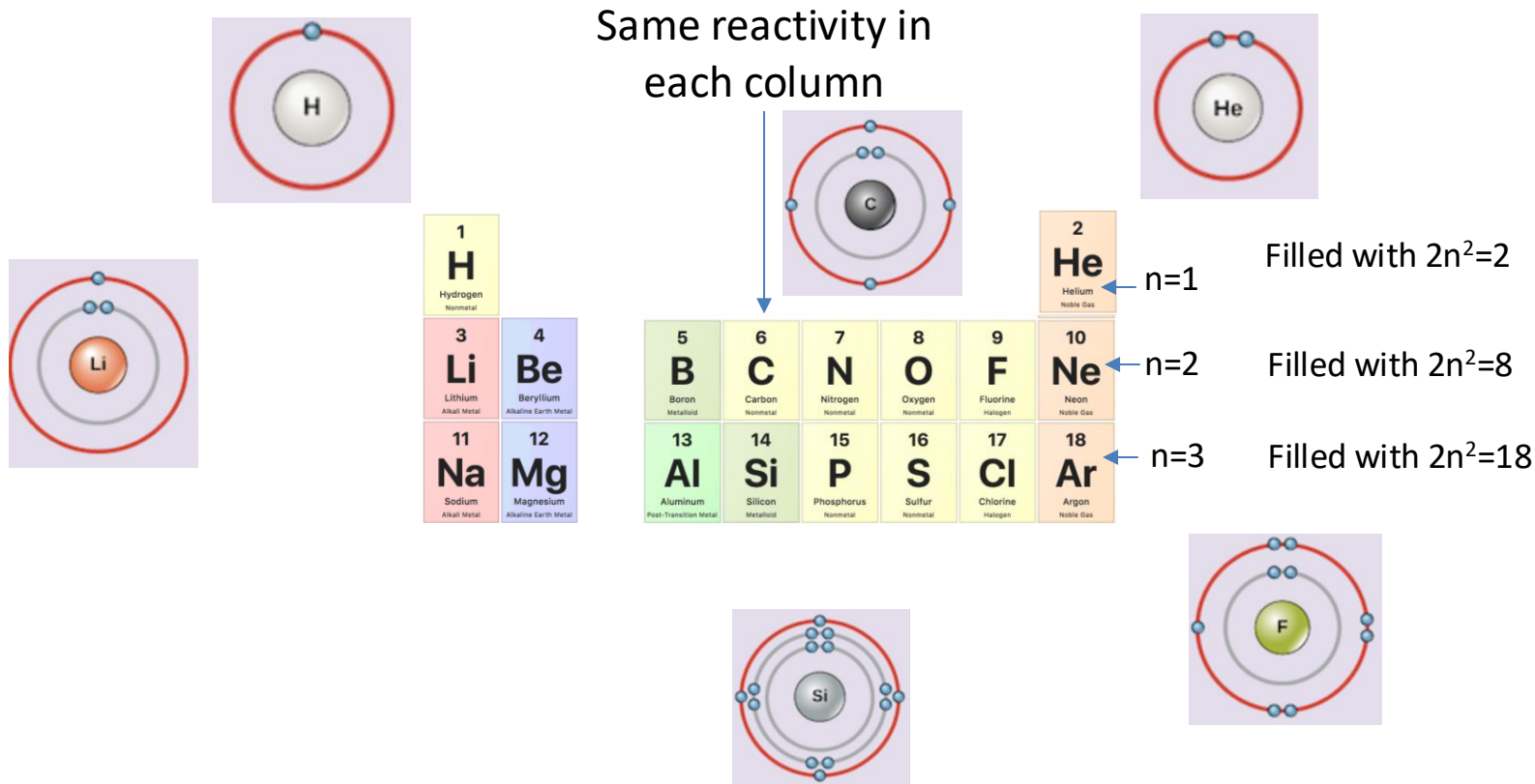
Formlabs 3 SLA printer

↑ stereo lithography.



Formlabs 3 SLA printer

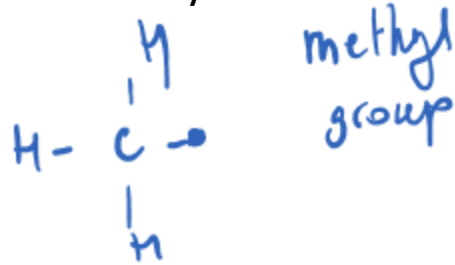
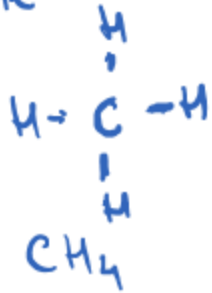




Single Carbon bonds

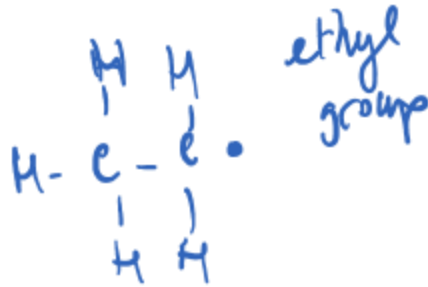
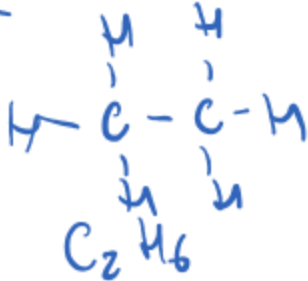
Alkane: \rightarrow H removed \rightarrow Alkyl:

methane



methyl group

ethane



ethyl group

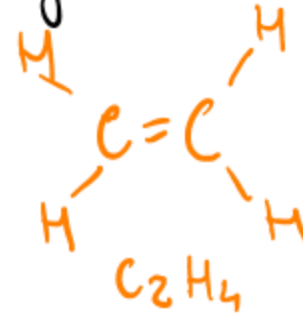
(propane) C_3H_8

Double Carbon bonds

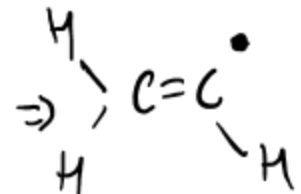
Alkene:

(ethene)

ethylene

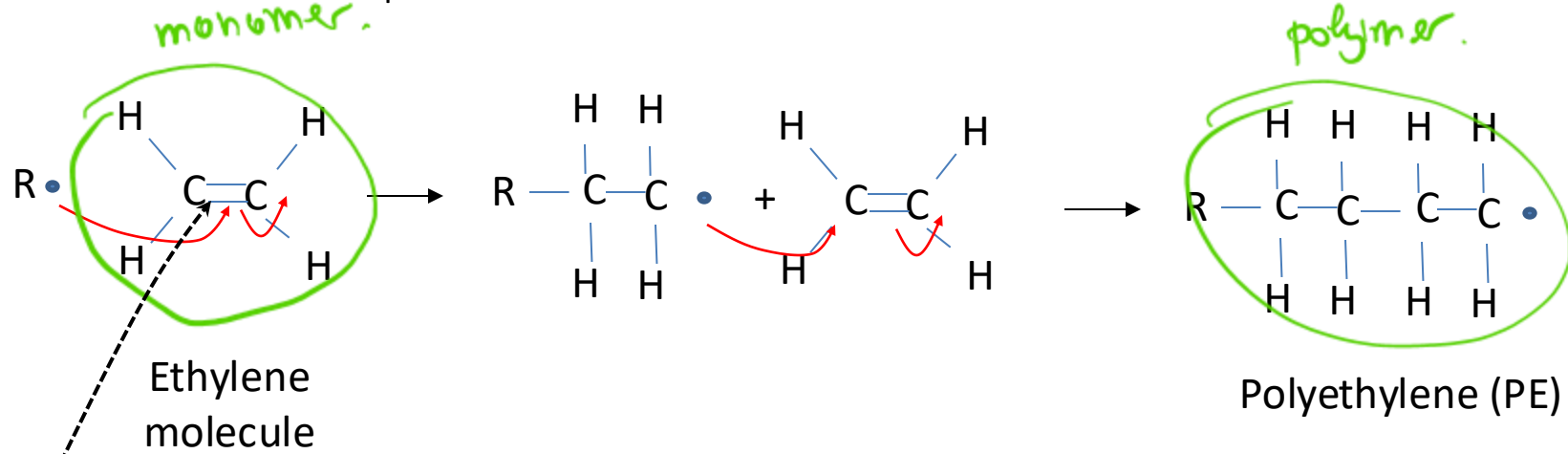


vinyl group



Radical chain Polymerization

$R\cdot$ Radical = molecule with unpaired electron

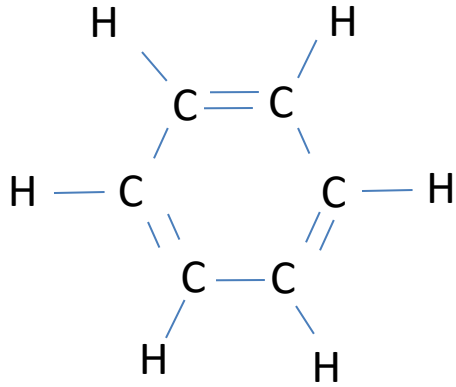


polymer chains \rightarrow thermoplastics

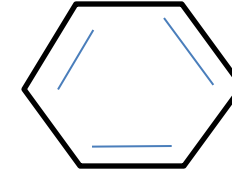
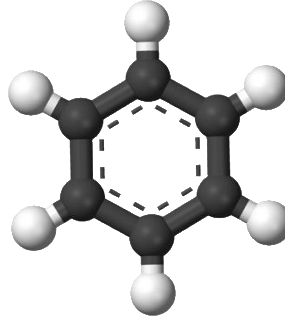
In a $C=C$ double bond,
one of the bond is weaker
(260 kJ/mol vs 350 kJ/mol)

The Radical R^* can be created by different energy sources:
heat, light etc..

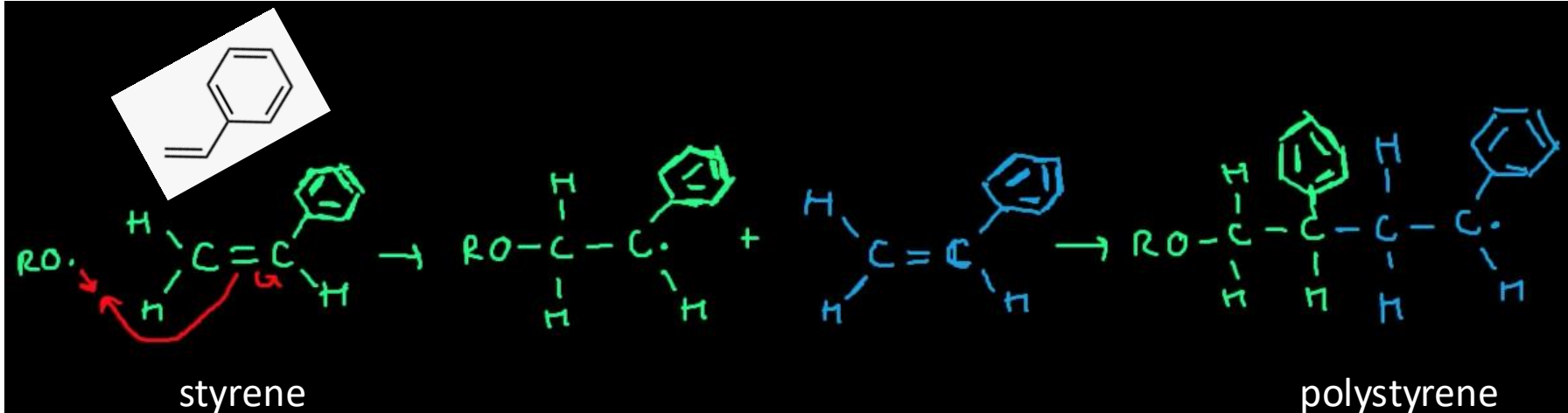
Radical chain Polymerization

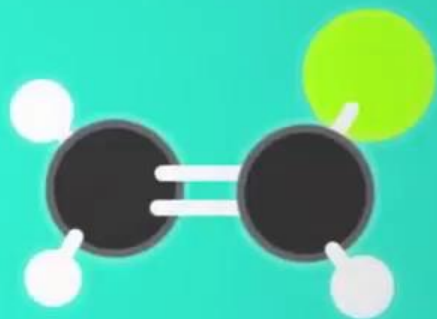


Benzene
ring



Simplified representation





Chemical components in a resin for Stereolithography

Photoinitiator

Monomers for crosslinking, mechanical strength

Absorbing dye (penetration depth)

Inhibitor (stabilizer for shelf life)

Monomer to tune viscosity

Acrylate
monomers:

PEA: polyethylacrylate

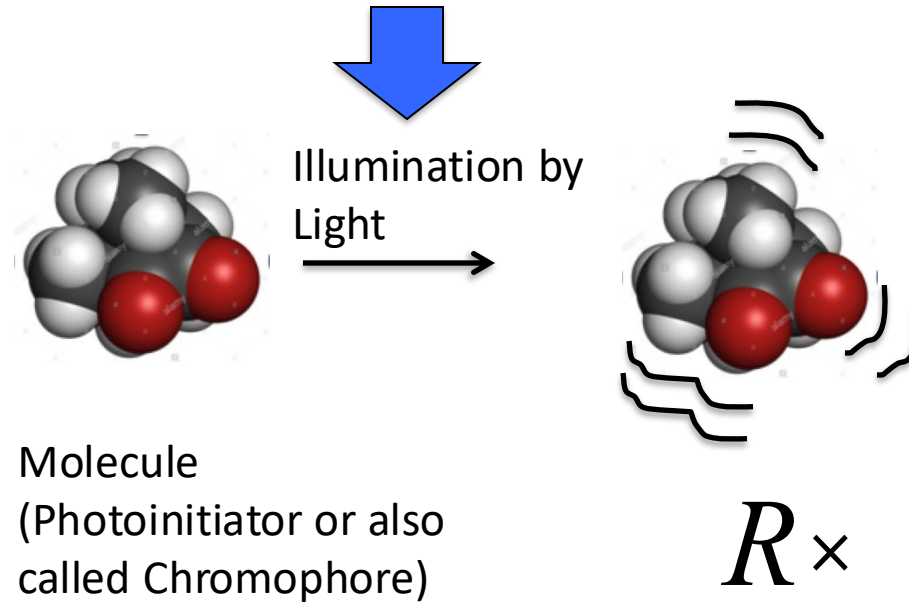
TMPTA:

DPEPA:

IBOMA

Photoinitiator

Photo induced Radical Polymerization



Excited State: Radical

The Photoinitiator ceases to absorb light once it is “converted” to a radical that induces polymerization

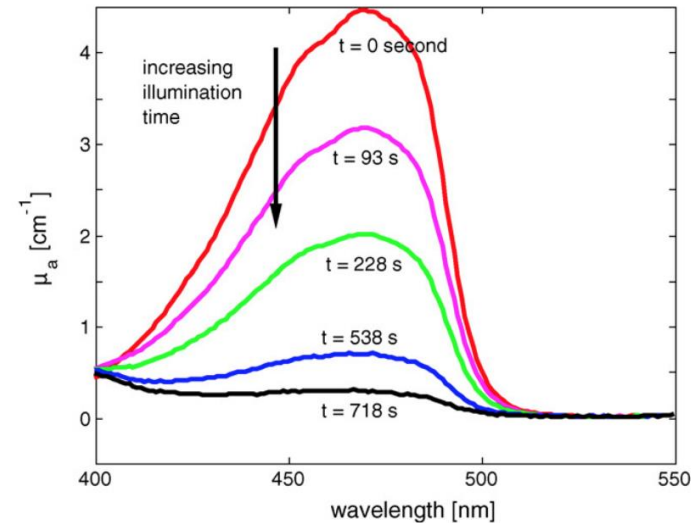
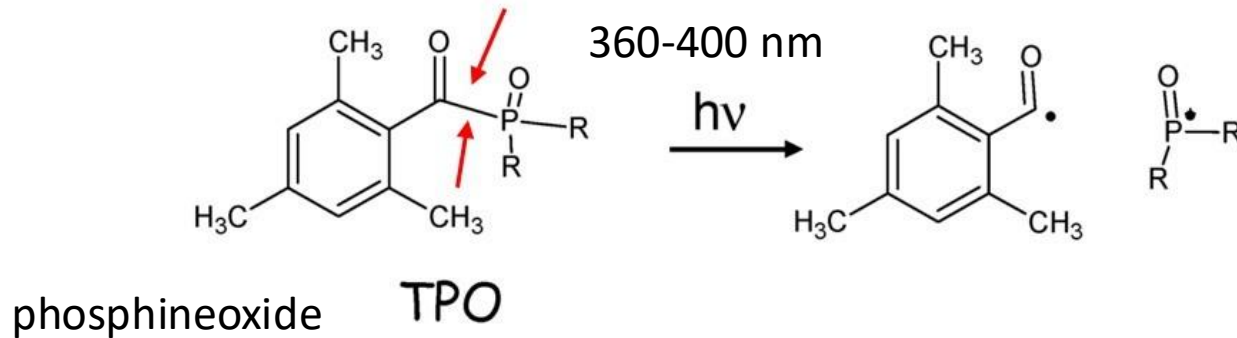
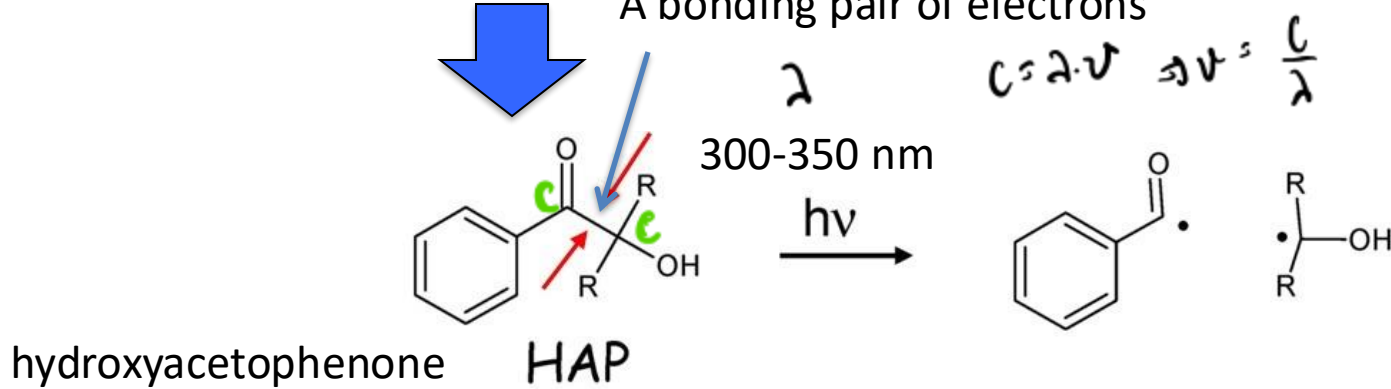


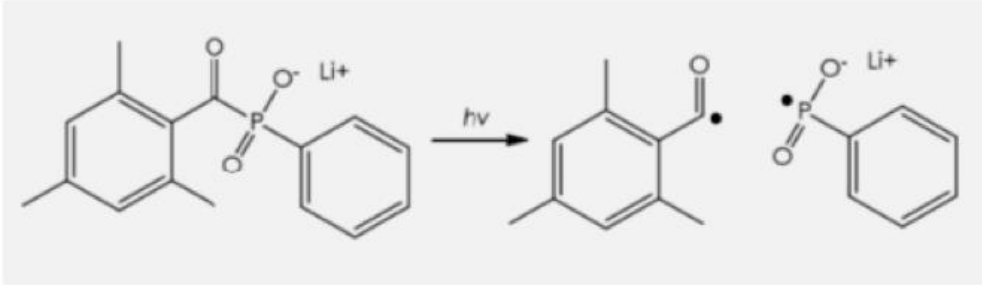
Fig. 6 – The absorption coefficient μ_a as a function of wavelength of resin with 0.7% CQ at five different illumination times for irradiance $E_{\text{total}} = 160 \text{ mW/cm}^2$

Type I photoinitiators

Light energy is used to cleave
A bonding pair of electrons



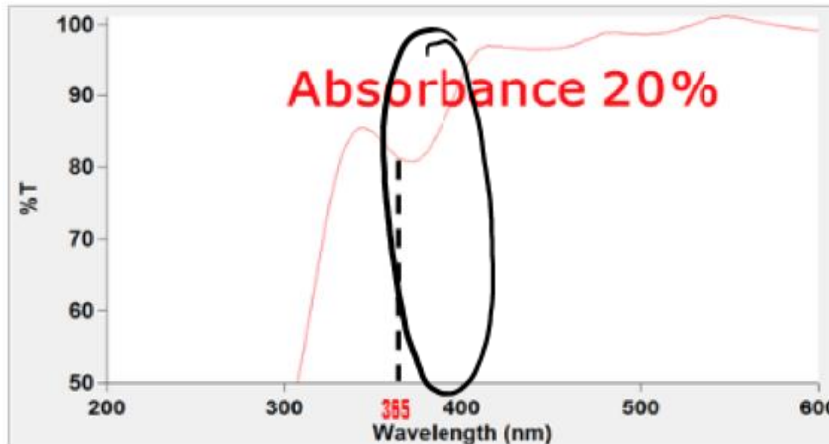
Type I photoinitiators



Lithium phenyl-2,4,6-trimethylbenzoylphosphinate (LAP)

(popular PI for
Hydrogels – high solubility in
Water

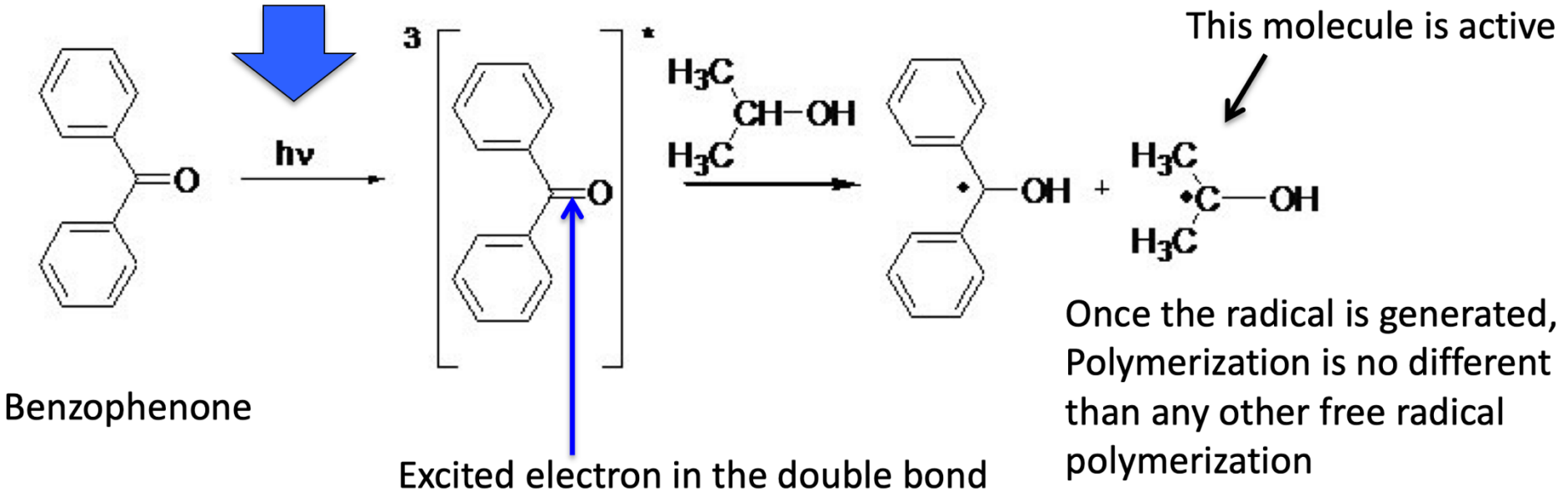
30 g/liter compared to
3 mg/liter for TPO)



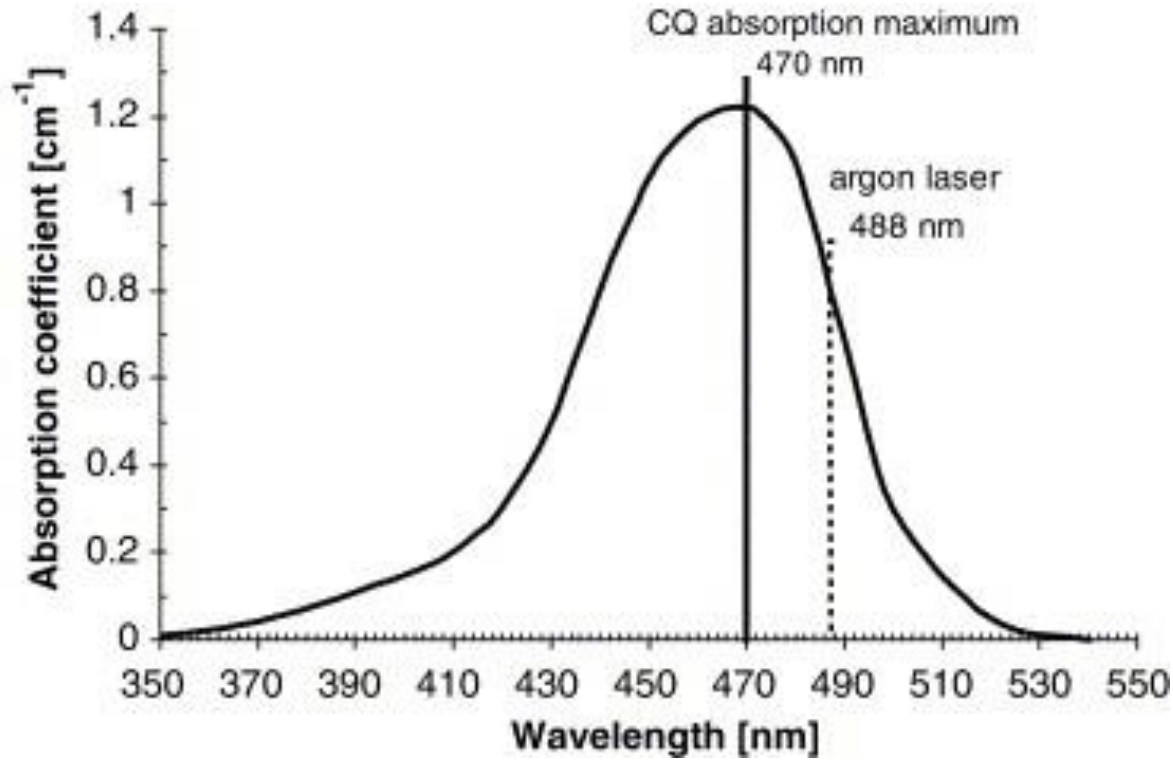
Type II photoinitiators

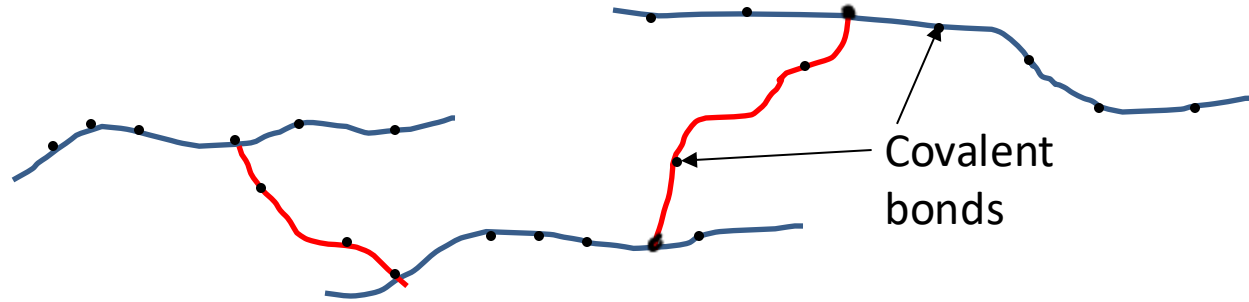
Less active than type I (one more step)

Need a co-initiator molecule to generate a Radical
Reacting molecule



The most widely used photoinitiator in dentistry is Camphorquinone (CQ).
It is a type II Photoinitiator





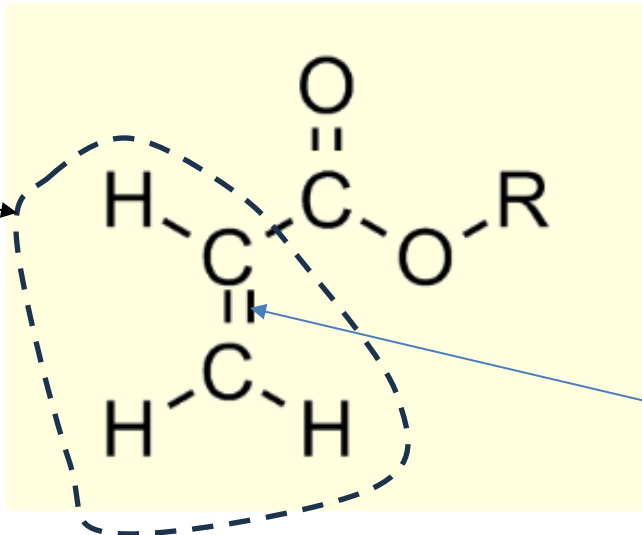
Need a monomer that can make chains via radical chain polymerization and link between chains (crosslinking) so that the curing is irreversible . The resin is called a thermoset.

It is not a thermoplastic (linear chains only, no cross linking), and thus there is no melting point for thermosets (only degradation with temperature)

Acrylate → important monomer in photopolymers



Vinyl
group



R :side chain (not a Radical !!)

Double bond used for radical
polymerization

Acrylate molecule

Example

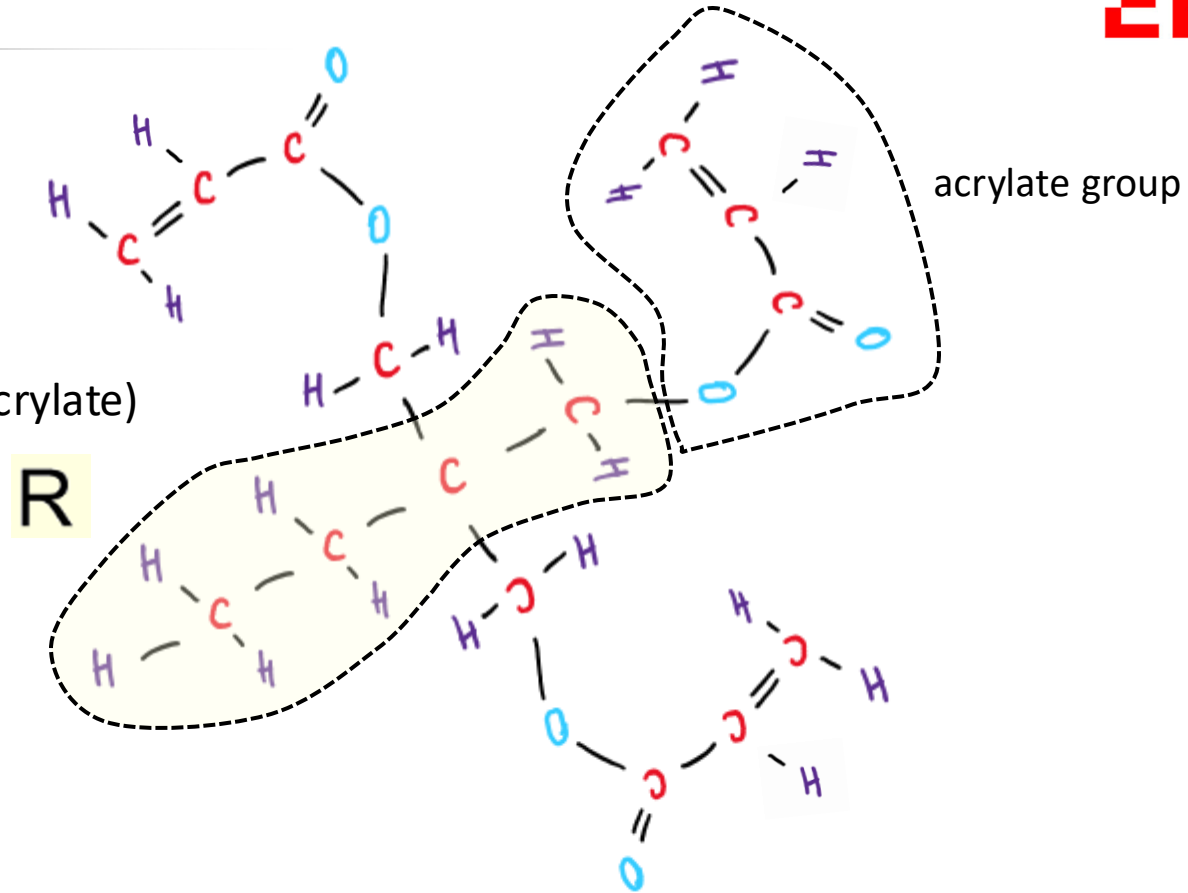
Monomer Molecule

TMPTA

(Trimethylolpropane triacrylate)

$C_{15}H_{20}O_6$

3 branches for
Cross linking



Criterion for gelation (liquid → solid)

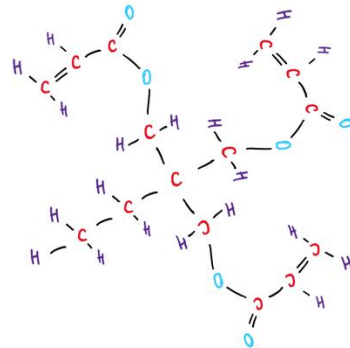
Flory criterion for gelation:

Fraction of reacted monomers $> \frac{1}{f-1} < 100\%$ f is called functionality

$f > 2$

functionality = number of reactive groups per monomer molecule that can participate in the polymerization reaction.

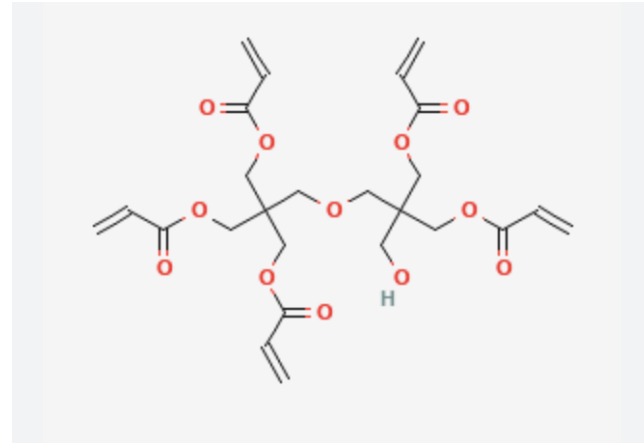
Example: TMPTA



$$f = 3$$

Gelation threshold = Fraction of reacted monomers: $> \frac{1}{3-1} = 50\%$

Dipentaerythritol pentaacrylate (DPEPA)



What is the gelation criterion ?

Gelation when fraction
of reacted monomers $> \frac{1}{5-1} = 25\%$

“Tough 2000” resin from Formlabs

From safety data sheet:

Hazard-determining components of labeling:

Urethane Dimethacrylate $\longrightarrow f = 2$

Methacrylate Monomer \longrightarrow the functionality of the monomer is not mentioned

Isobornyl methacrylate $\longrightarrow f = 1$

Phenyl bis(2,4,6-trimethylbenzoyl)-phosphine oxide \longrightarrow Photoinitiator

When a resin is a mix of monomers with different functionalities, then the average functionality \bar{f} is used in the Flory criterion:

$$\bar{f} = \frac{\sum_i x_i f_i}{\sum_i x_i}$$

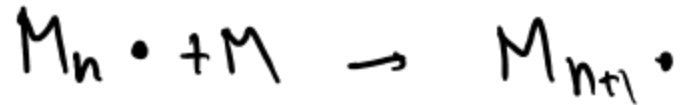
x_i : fraction of component i
 f_i : functionality of component i

for $\bar{f} > 2$, the functionality of the unknown monomer must be 3 or more

Photo-initiation



Propagation
Polymer chain growth

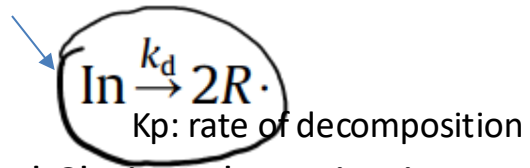


Oxygen radical
scavenging



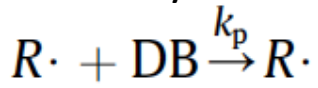
Reaction kinetics

Photoinitiator molecule



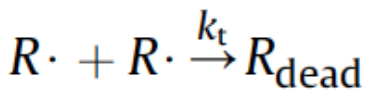
**Photo
initiator**

Radical Chain Polymerization



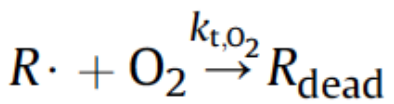
k_p : rate of propagation

Radicals



k_t : rate of termination

**Monomer
Double bond**



k_{t,O_2} : rate of termination

Oxygen

rate

$\frac{P}{\text{area}}$ \swarrow light intensity

$$\frac{d[\text{In}]}{dt} = -k_d \cdot \frac{I_0}{I(\cdot)} [\text{In}]$$

generation

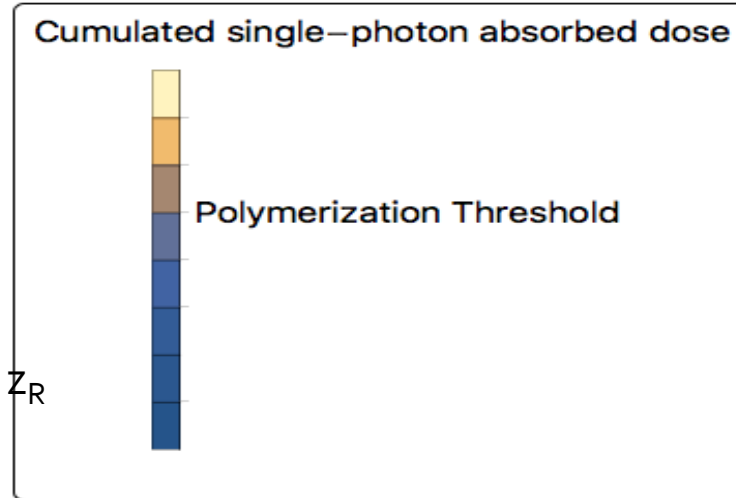
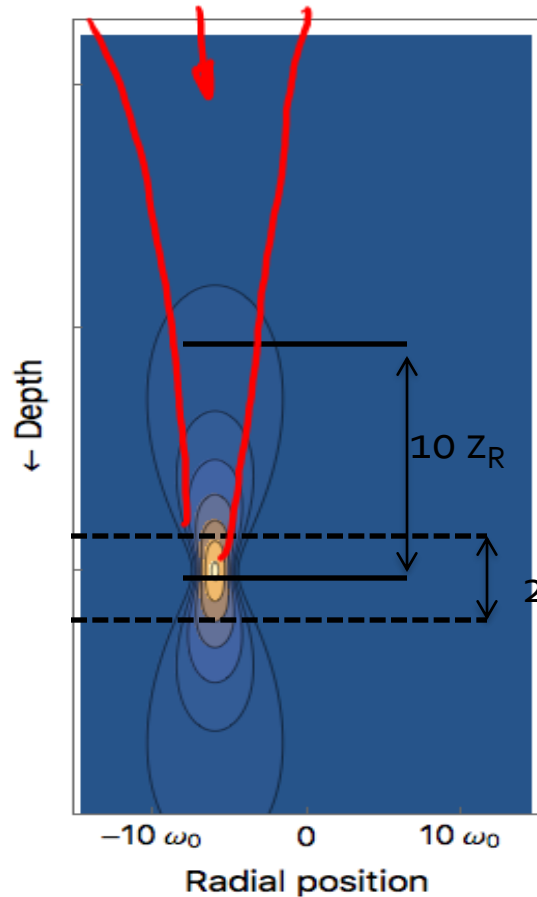
$$\frac{d[\text{R}\cdot]}{dt} = + 2k_d \frac{I_0}{I(\cdot)} [\text{In}] - [\text{O}_2][\text{R}\cdot] \cdot k_{\text{O}_2} - 2k_t [\text{R}\cdot]^2$$

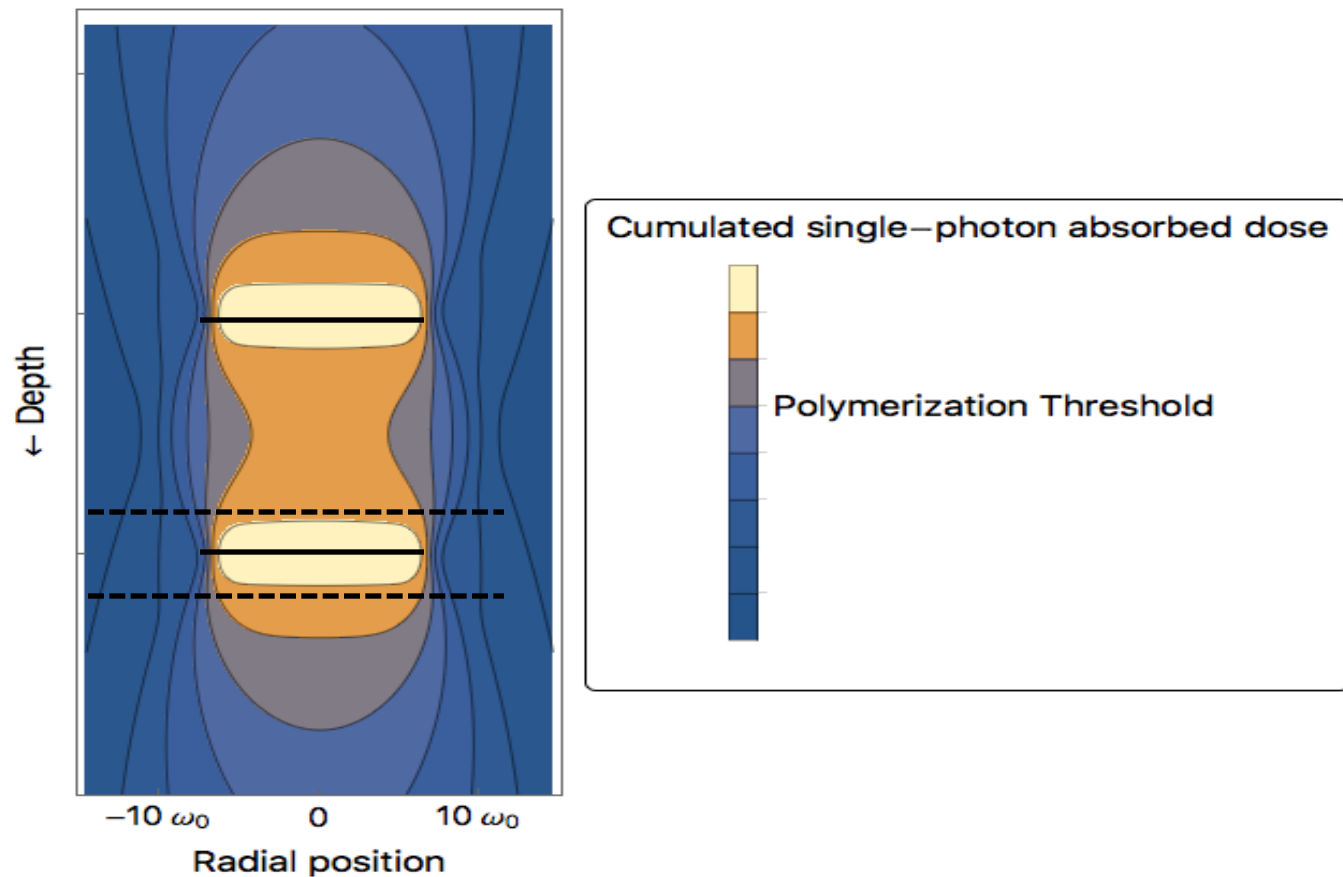
$$\frac{d[\text{DB}]}{dt} = -k_p [\text{DB}][\text{R}\cdot]$$

$$\frac{d[\text{O}_2]}{dt} = -k_{\text{O}_2} [\text{R}\cdot][\text{O}_2] + D_{\text{O}_2} \cdot \frac{\partial^2 [\text{O}_2]}{\partial z^2}$$

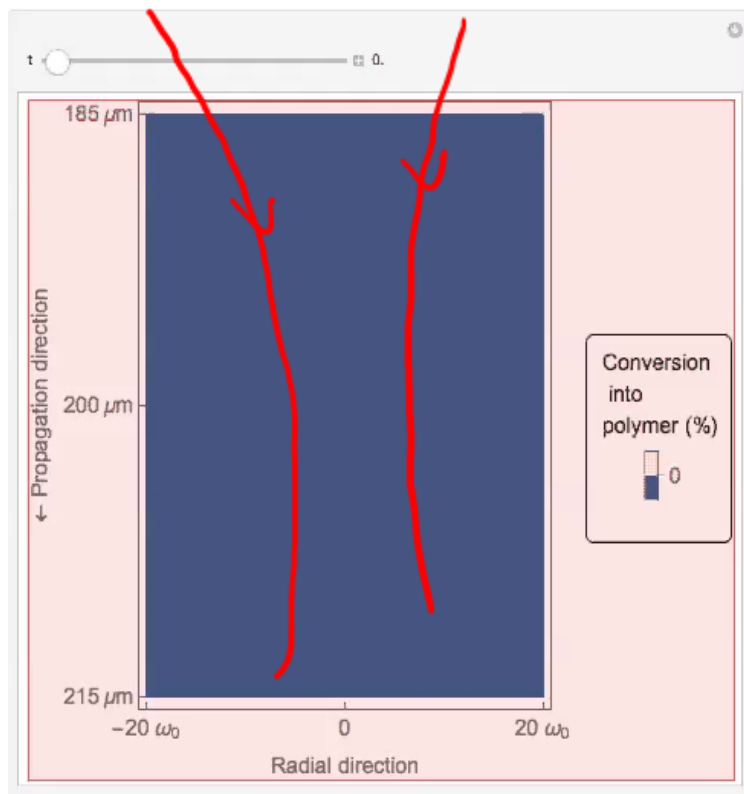
diffusion

Linear absorption and photopolymerization

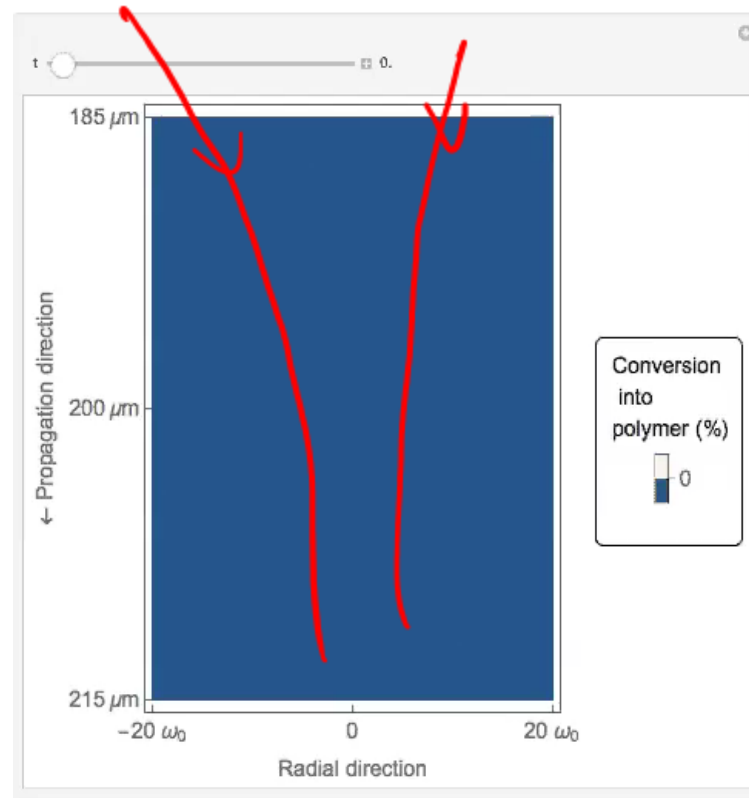




Simulation without oxygen inhibition

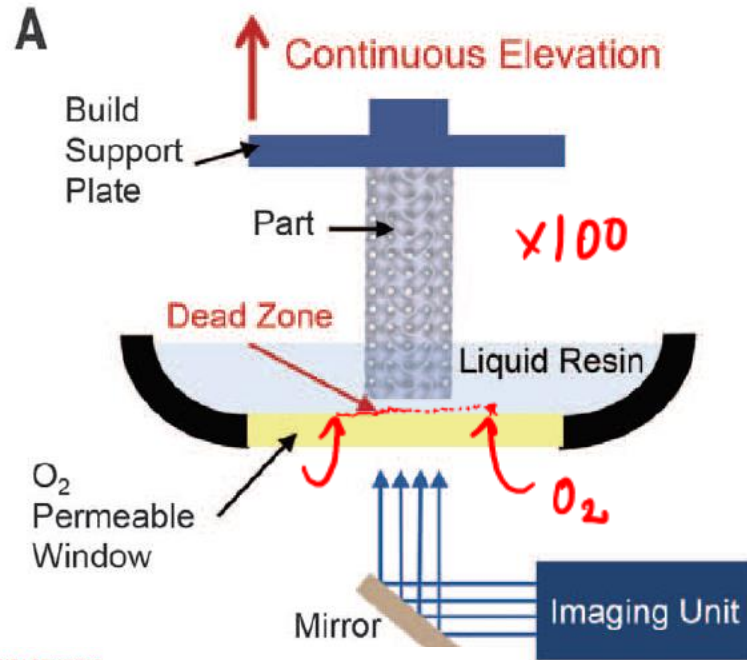


Simulation with oxygen inhibition



P = 250 nW, polymer: PEG-DA

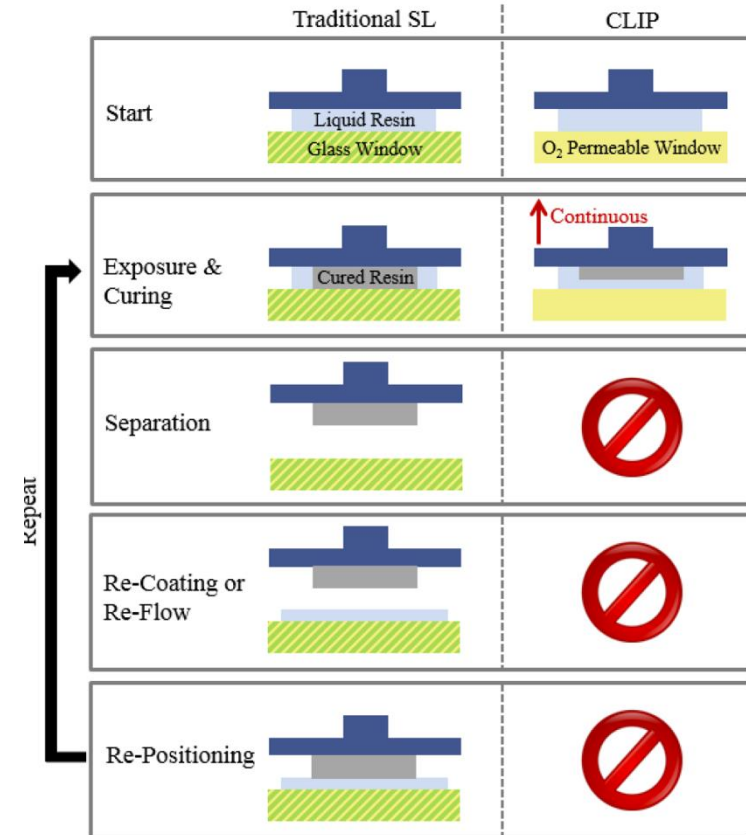
Continuous liquid interface production (CLIP) **EPFL**



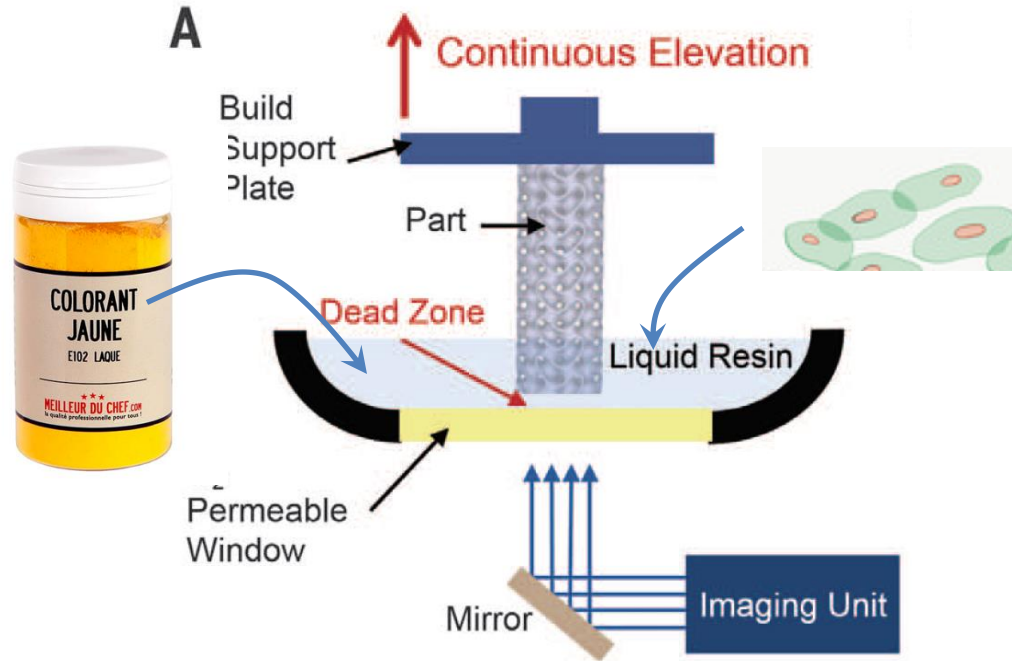
ADDITIVE MANUFACTURING

Continuous liquid interface production of 3D objects **Science**

John R. Tumbleston,¹ David Shirvanyants,¹ Nikita Ermoshkin,¹ Rima Januszewicz,² Ashley R. Johnson,³ David Kelly,¹ Kai Chen,¹ Robert Pinschmidt,¹ Jason P. Rolland,¹ Alexander Ermoshkin,^{1*} Edward T. Samulski,^{1,2*} Joseph M. DeSimone^{1,2,4*}



<https://www.carbon3d.com/our-technology/>



Projection Stereolithography

